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03599.000083.

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re Application of:
TOMIO NAKAYAMA, et al.

Application No.: 10/725,403

Filed: December 3, 2003

For: PLASMA PROCESSING
APPARATUS AND METHOD

Examiner: L. Alejandro Mulero
Group Art Unit: 1763
December 2, 2005

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents, together with English-language abstracts, are enclosed.

The listed documents were cited in an Official Action in a corresponding Korean application. A copy of the Korean Official Action, which is dated August 31, 2005, is enclosed. An English-language translation of the Official Action is also enclosed.

This Information Disclosure Statement is being filed before the issuance of a first Office Action on the merits. Therefore, no fee under 37 C.F.R. § 1.97(c)(2) is believed due. Nevertheless, the Commissioner may charge Deposit Account No. 06-1205, should any fee be due for filing this paper.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

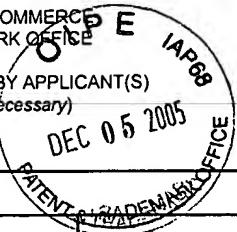
Applicants' undersigned attorney may be reached in our Costa Mesa, California office at (714) 540-8700. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,



Damond E. Vadnais
Attorney for Applicants
Registration No.: 52,310

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New York, New York 10112-3800
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U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICELIST OF REFERENCES CITED BY APPLICANT(S)
(Use several sheets if necessary)

APPLICANT

TOMIO NAKAYAMA, et al.

FILING DATE

December 3, 2003

GROUP

1763

U.S. PATENT DOCUMENTS

| *EXAMINER INITIAL | | DOCUMENT NUMBER | DATE | NAME | CLASS | SUBCLASS | FILING DATE IF APPROPRIATE |
|-------------------|--|-----------------|------|------|-------|----------|----------------------------|
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FOREIGN PATENT DOCUMENTS

| | | DOCUMENT NUMBER | DATE | COUNTRY | CLASS | SUBCLASS | TRANSLATION YES/NO/ OR ABSTRACT |
|--|--|-----------------|----------|---------|-------|----------|---------------------------------|
| | | 10-340892 | 12/22/98 | Japan | | | Abstract |
| | | 8-274067 | 10/18/96 | Japan | | | Abstract |
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OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 1

Form #61